



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Masumi Sakai

Attorney Docket No.: SMDZP106
(0800239.0129)

Application No.: 09/779,125

Examiner: A.C. Lavarias

Filed: February 7, 2001

Group: 2872

Title: FURNACE-TYPE ATOMIC
ABSORPTION SPECTROPHOTOMETER

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on January 22, 2003.

Signed: Deborah Neill
Deborah Neill

Drawing Corrections
Approved
JCL
1/28/03

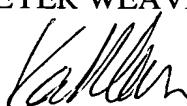
**SEPARATE LETTER TO EXAMINER
REQUESTING APPROVAL OF DRAWING CHANGES**

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicant proposes to amend the original drawings as indicated in red (or highlighted) in the enclosed photocopies. The approval of the Examiner is hereby requested. If there are any questions concerning this matter, please call the undersigned at the telephone number below.

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP


Keiichi Nishimura
Registration No. 29,093

P.O. Box 778
Berkeley, CA 94704-0778
(510) 843-6200

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